



AF/IFW

**RESPONSE UNDER 37 C.F.R. § 1.116
EXPEDITED PROCEDURE REQUESTED
EXAMINING GROUP 2811**

PATENT

Customer No. 22,852
Attorney Docket No. 4329.3196

IN THE UNITED STATES PATENT AND TRADEMARK OFFICE

In re Application of:)
Takamasa USUI)
Application No.: 10/734,106) Group Art Unit: 2811
Filed: December 15, 2003)
For: SEMICONDUCTOR DEVICE) Examiner: Stephen Ho Yin Loke
USING INSULATING FILM OF)
LOW DIELECTRIC CONSTANT) Confirmation No.: 4860
AS INTERLAYER INSULATING)
FILM)
For: Mail Stop AF)

Commissioner for Patents
P.O. Box 1450
Alexandria, VA 22313-1450

Sir:

AMENDMENT AFTER FINAL

In reply to the Final Office Action mailed July 13, 2005, the period for response to which extends through October 13, 2005, and pursuant to 37 C.F.R. § 1.116, Applicant proposes that this application be amended as follows:

Amendments to the Claims are reflected in the listing of claims in this paper.

Remarks follow the amendment sections of this paper.